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Confirmation Letter

To,

DAYASHANKER

Published in : Volume 9 | Issue 6 | 2022-06-29



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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Editor In Chief

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